



PATENT APPLICATION

2814

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshaiah Fainman

Serial No.: 10/521,425

Conf. No.: 9057

Filed: 3/22/2005

For: HOLOGRAPHICALLY DEFINED SURFACE  
MASK ETCHING METHOD AND ETCHED OPTICAL  
STRUCTURES

Art Unit: 2814

Examiner: Rao, Shrinivas H.

)  
I hereby certify that this paper is being deposited with  
the United States Postal Service as FIRST-CLASS mail  
in an envelope addressed to: Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450, on this  
date.  
S/H/R  
Date F-CLASS.WCM Registration No. 43,874  
Appr. February 20, 1998  
Attorney for Applicant(s)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL

Dear Sir:

Transmitted herewith is a communication regarding the above-identified application.

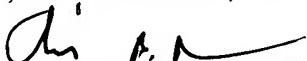
Fee Calculation For Claims As Amended

	As Amended	Previously Paid For	Present Extra	Rate	Additional Fee
Total Claims	21	- 21	= 0	x \$ 50.00	= \$ 0
Independent Claims	3	- 3	= 0	x \$200.00	= \$ 0
Fee for Multiple Dependent Claims				\$360.00	= \$ 0
				Total Additional Fee	\$ 0
				Small Entity Fee (reduced by half)	\$ 0

- (X) Amendment A.  
(X) Supplemental Information Disclosure Statement wth \$180 check; Form PTO 1449;  
Cited documents.  
(X) If a Petition under 37 C.F.R. §1.136(a) for an extension of time for response is required to make the attached response timely and does not separately accompany this transmittal, Applicant(s) hereby petition(s) under 37 C.F.R. §1.136(a) for an extension of time for response in the above-identified application for the period required to make the attached response timely.  
(X) The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

GREER, BURNS &amp; CRAIN, LTD.

By:   
Arik B. Ranson, Reg. No. 43,874

August 7, 2007  
300 South Wacker Drive – Suite 2500  
Chicago, Illinois 60606  
Tel.: (312) 360-0080  
Fax: (312) 360-9315  
Customer No.: 24978



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8/1/07

*d. r.*

Registration No. 43874

Date

F-CLASS.WCM

Appr. February 20, 1998 Attorney for  
Applicant(s)

AMENDMENT A

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed May 7, 2007.